

02 1031  
09/027234

TUNNELING SENSOR WITH LINEAR FORCE REBALANCE AND  
METHOD FOR FABRICATING THE SAME

ABSTRACT

clw  
A tunneling sensor ~~is disclosed~~ <sup>has</sup> having a pair of force  
2 rebalance capacitors that are used in a push-pull relationship so  
3 as to provide a rebalance force that is a linear function of  
4 applied rebalance voltages, which leads to an output voltage that  
5 is linearly related to input acceleration. The tunneling sensor  
6 comprises a plate electrode that is formed from and attached to a  
7 silicon substrate by a pair of torsional flexures, which provide  
8 an axis of rotation for the plate electrode. A pendulous mass is  
9 formed on a first end of the plate electrode, and a tunnel-effect  
10 contact is formed on a second end of the plate electrode. A pair  
11 of torque rebalance bridge electrodes are formed on the substrate  
12 so as to span the plate electrode. A tunnel-effect tip is formed  
13 on the substrate so as to be proximate the tunnel-effect contact  
14 and in line with the rotational path that the tunnel-effect  
15 contact takes when the plate electrode is rotated.